

# Charge collection in GridPix detectors as a function of pixel pad size

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- GridPix model
- How I run Garfield++ and field simulations
- Avalanche spread
- Refine model
- Charge collection

# Model

## Geometry

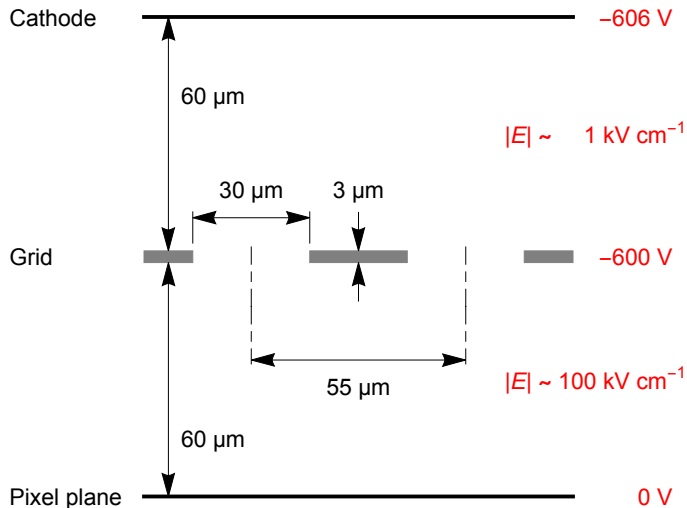
- Hole diameter:  $30\ \mu\text{m}$
- Amplification gap:  $60\ \mu\text{m}$

## Fields

- Drift:  $1\ \text{kV cm}^{-1}$
- Amplification:  $100\ \text{kV cm}^{-1}$

## Gas

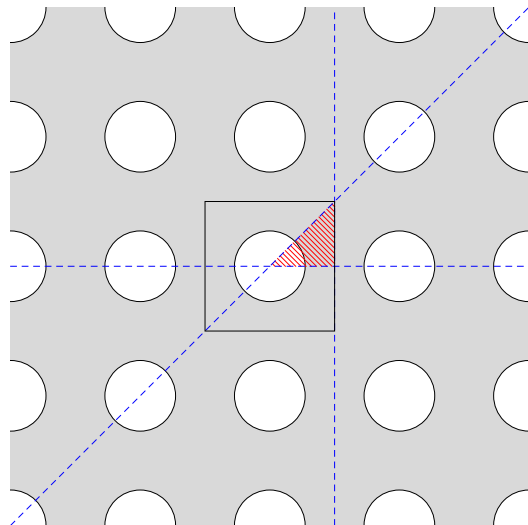
- DME(50 %)/CO<sub>2</sub>(50 %)



# Meshing and field simulation

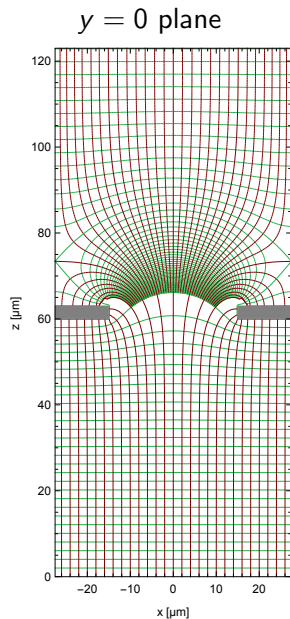
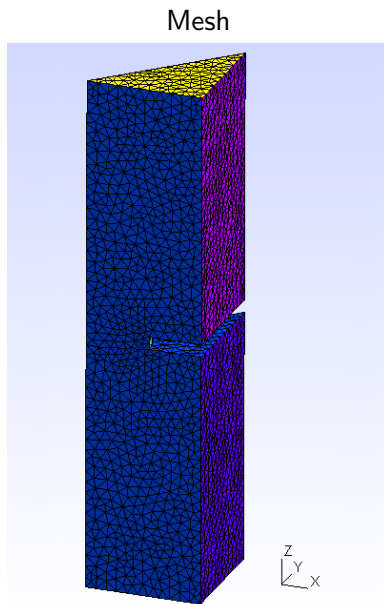
- Use mirror symmetries to reduce number of finite elements in field and detector simulation
- Boundary condition on planes of mirror symmetry:  $\nabla V \cdot \hat{n} = 0$
- Only simulate fields in shaded region

Top view

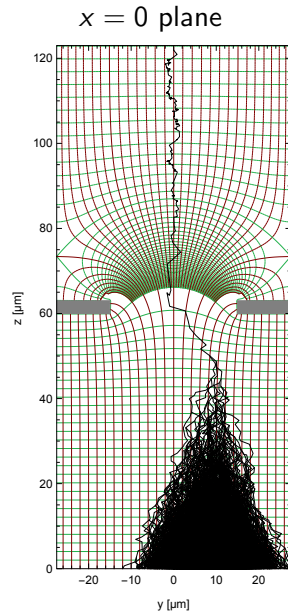
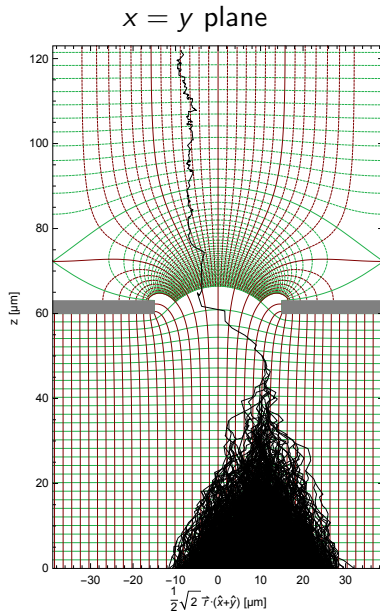
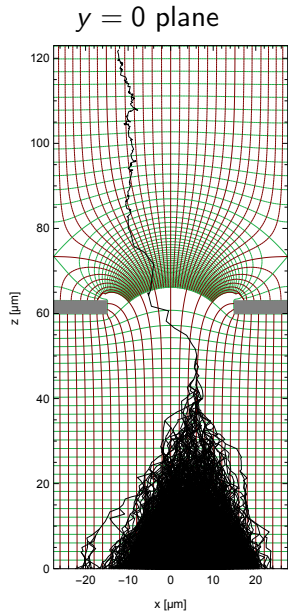


# Meshing and field simulation

- We mesh the geometry with Gmsh
  - 3D finite element grid generator (free software)
- We use Elmer to simulate the field
  - Open source multiphysical simulation software mainly developed by CSC-IT Center for Science
- To save CPU, the mesh only extends up to  $123\ \mu\text{m}$ . Above that, the field is constant.



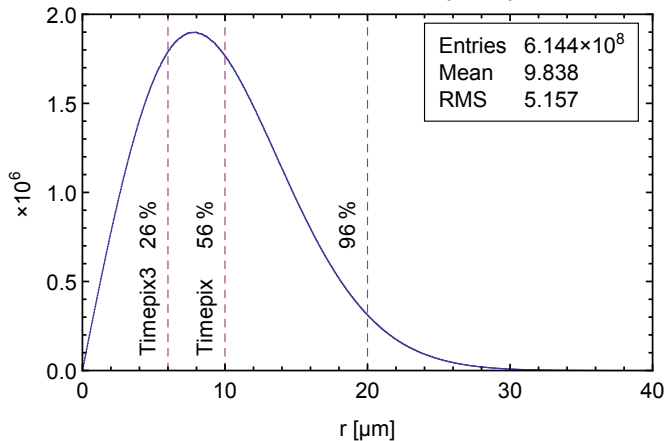
# Avalanche simulation



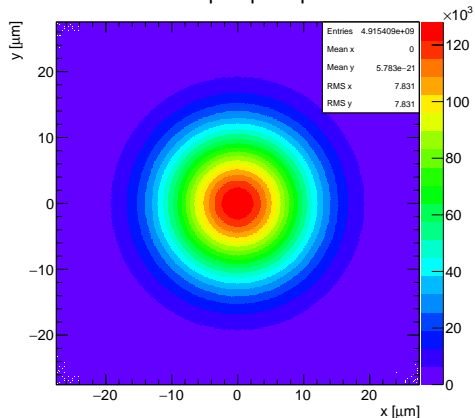
## Secondary electron endpoints

- For this model, charge collection efficiency is 26 % for a 12  $\mu\text{m}$  diameter pad
- However, in a more realistic model, not all electrons end on electrodes

Electron r distribution at pixel plane



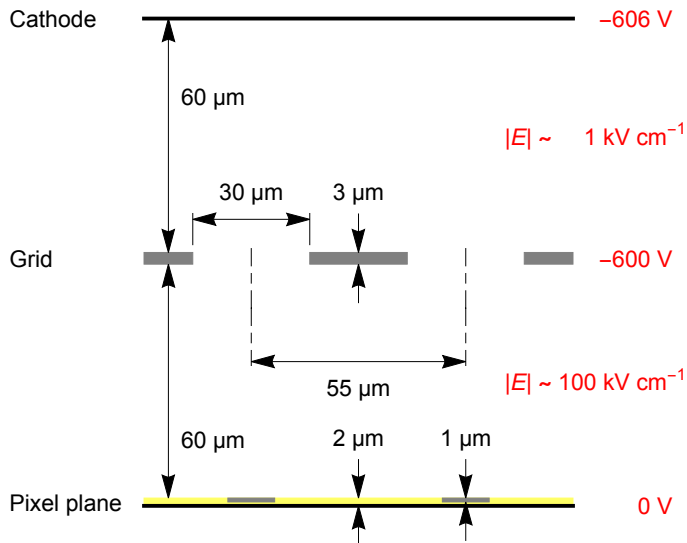
Hit map at pixel plane



# Elevated pad

## Geometry

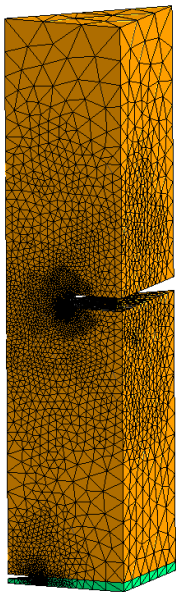
- Added pad electrode in order to use Shockley-Ramo
- Pad embedded in  $\text{SiO}_2$  dielectric
- Vary pad diameter



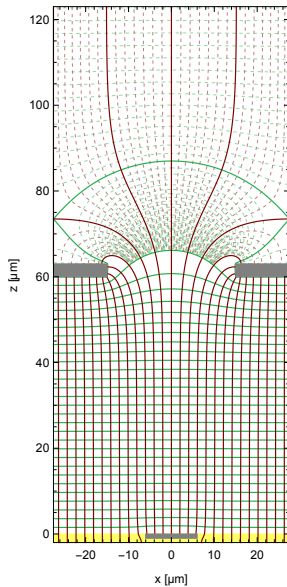


# Elevated pad

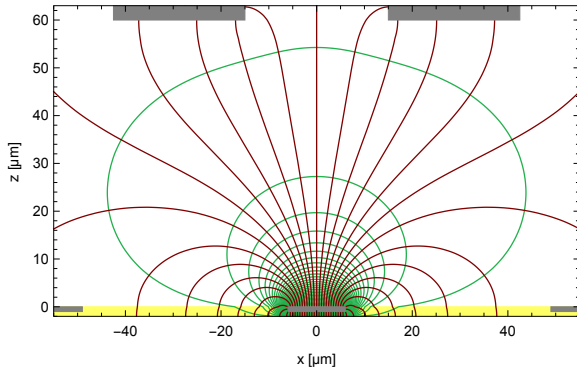
Mesh



E-field



W-field



# Shockley-Ramo theorem

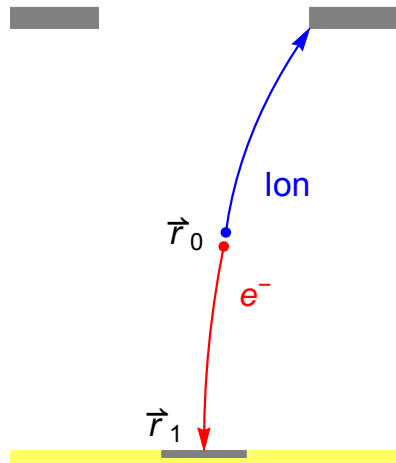
- Instantaneous current on pad given by

$$I = \frac{-q\vec{E}_w \cdot \vec{v}}{1V}$$

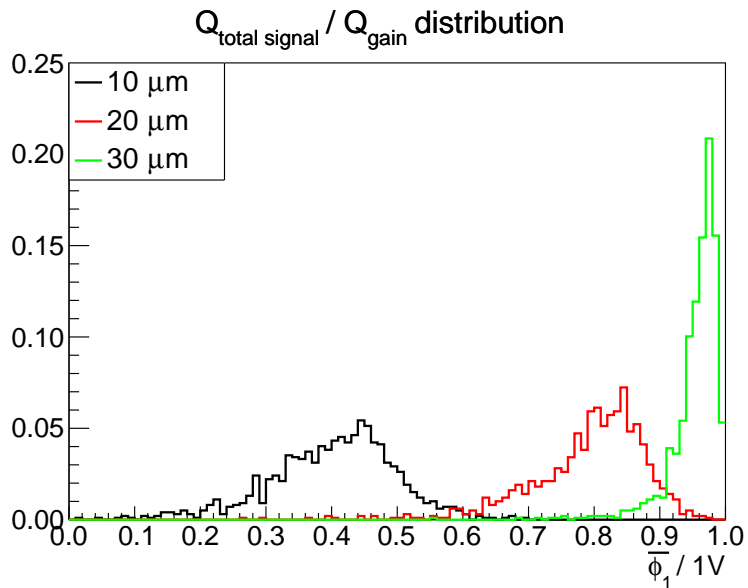
- Integrated signal:

$$\int_{t_a}^{t_b} I dt = \frac{q}{1V} [\phi(\vec{r}_b) - \phi(\vec{r}_a)]$$

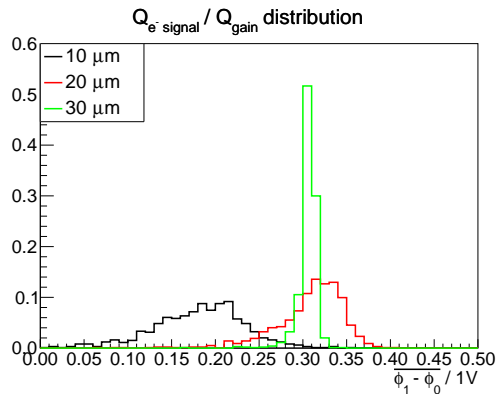
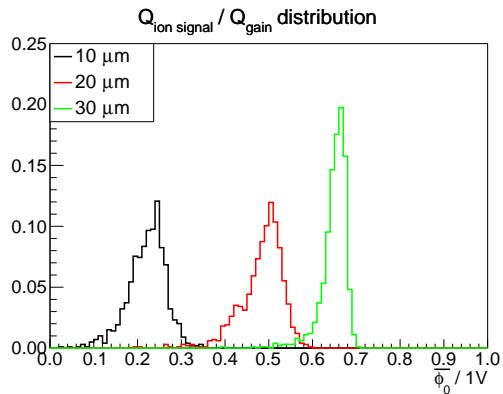
- Charge induced by electron:  $Q_{e^-} = \frac{-e}{1V} [\phi(\vec{r}_1) - \phi(\vec{r}_0)]$
- Charge induced by ion:  $Q_{ion} = \frac{e}{1V} [0V - \phi(\vec{r}_0)]$
- Total induced charge:  $Q = Q_{e^-} + Q_{ion} = \frac{-e}{1V} \phi(\vec{r}_1)$



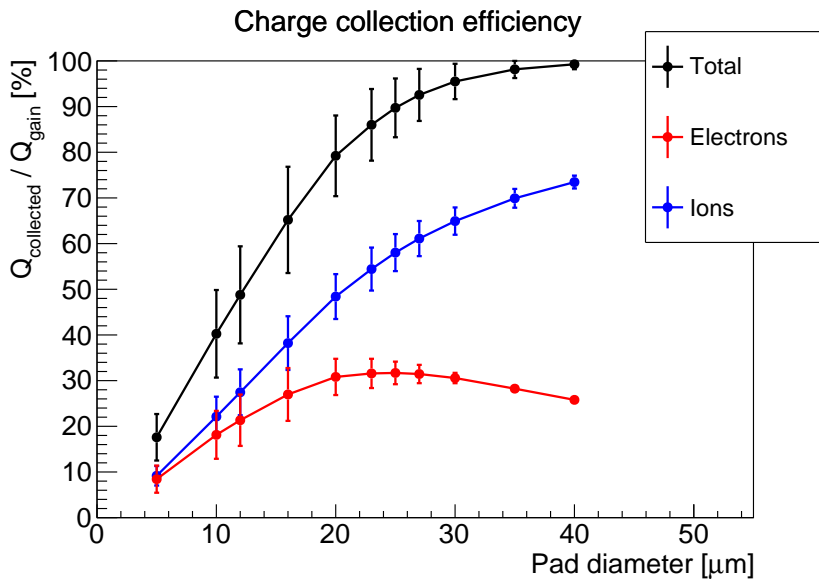
# Charge collection efficiency



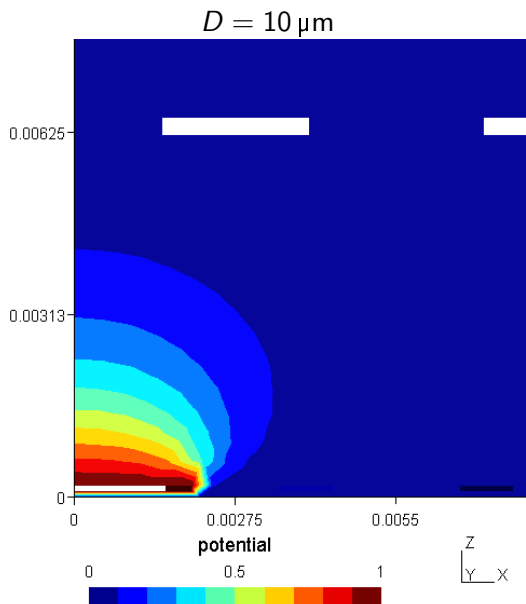
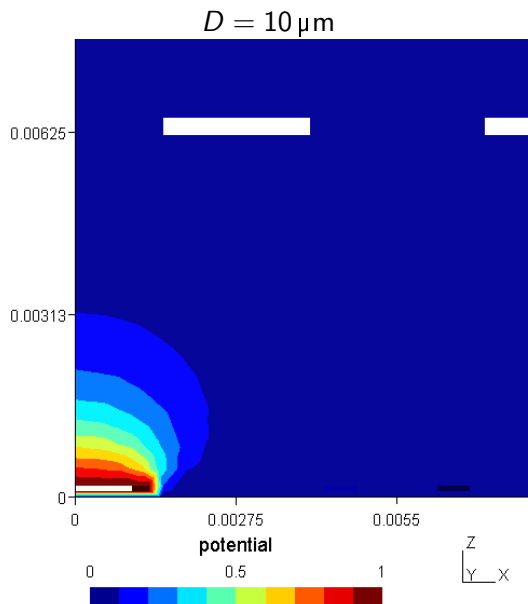
# Charge collection efficiency



# Charge collection efficiency

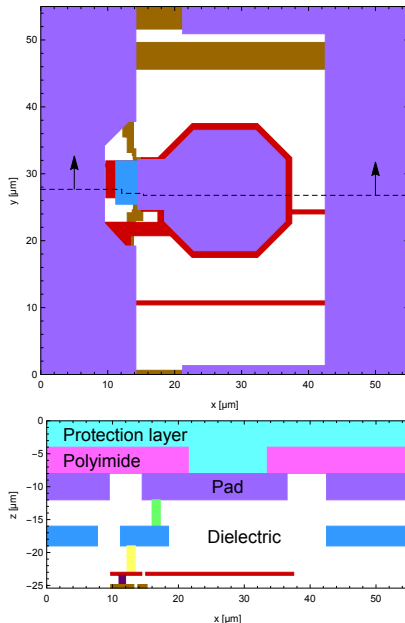
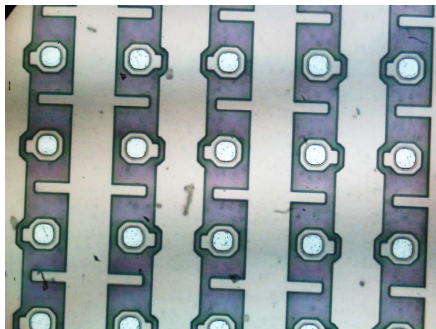


# Weighting potential

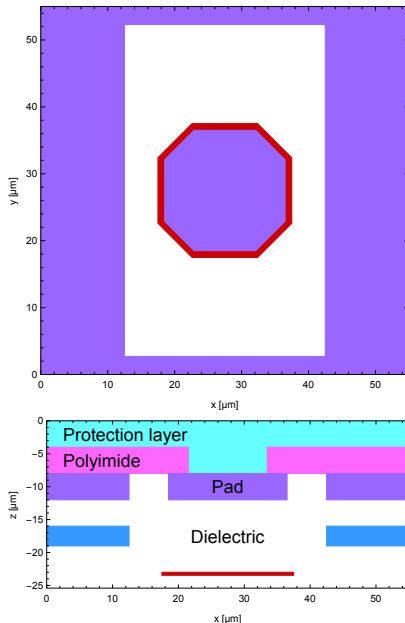
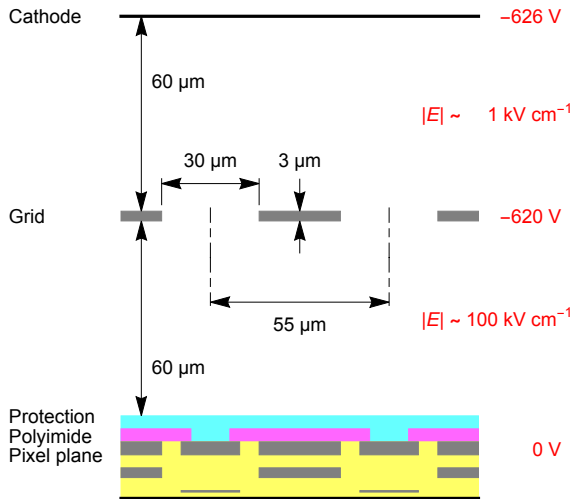


# Realistic Timepix3 model

- Make an approximation of TPX3 top metal layers
- Pad is actually  $18\ \mu\text{m}$  in diameter, not  $12\ \mu\text{m}$



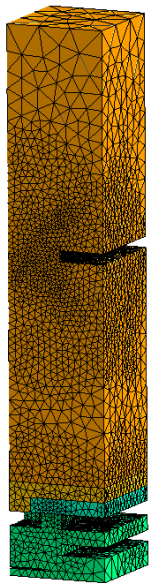
# Realistic Timepix3 model



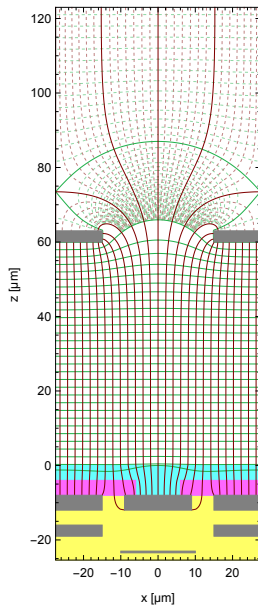


# Realistic Timepix3 model

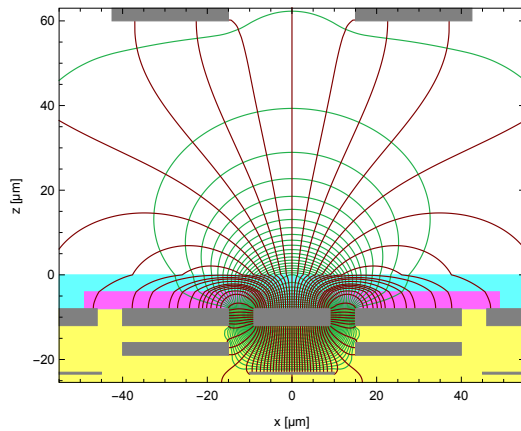
Mesh



E-field

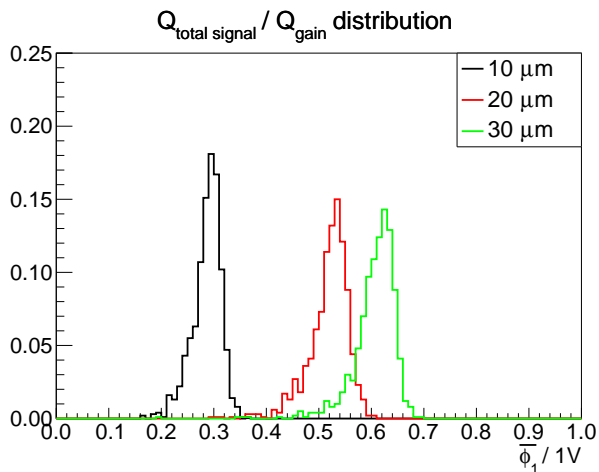


W-field

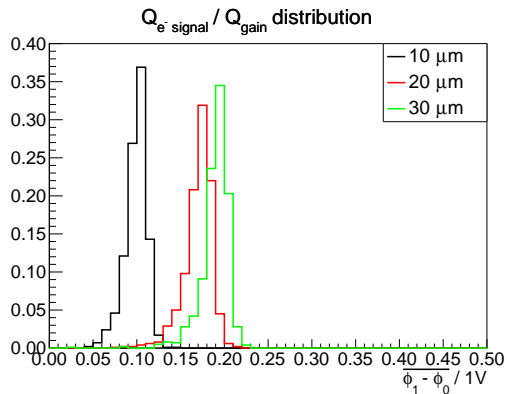
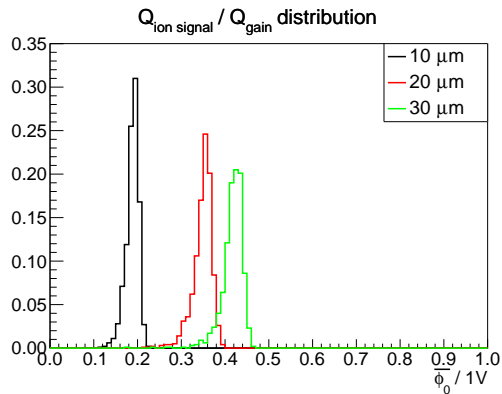


# Charge collection efficiency

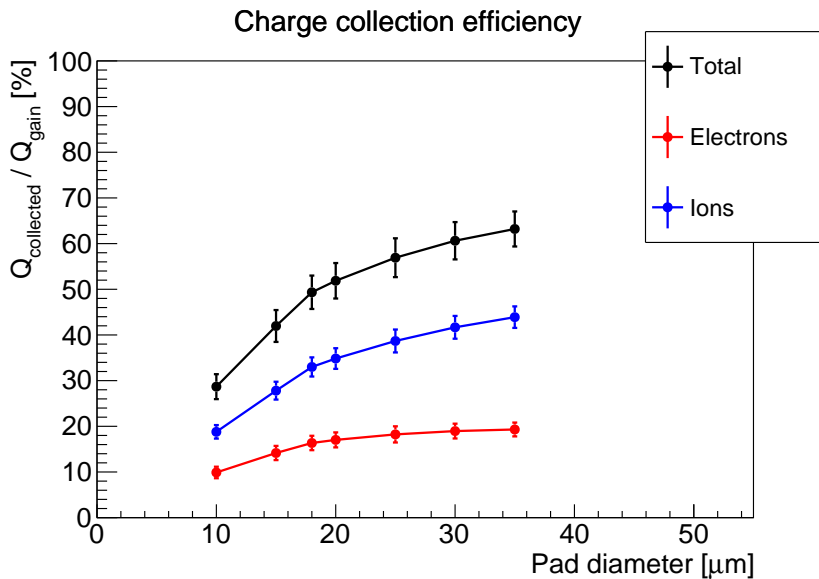
- Induced charge lower due to protection layers above, and metal layers around pad



# Charge collection efficiency



# Charge collection efficiency



# Conclusions and outlook

## Conclusions:

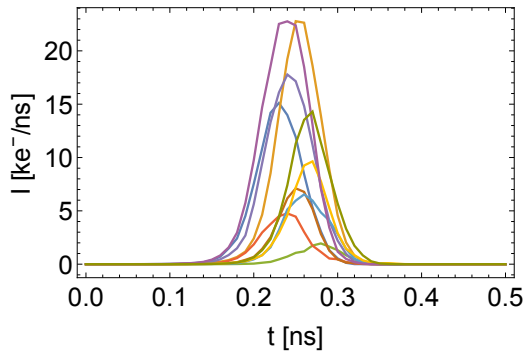
- We might see only a small part of the avalanche.
- Bigger pad size can increase the (charge-integrated) signal

## Outlook:

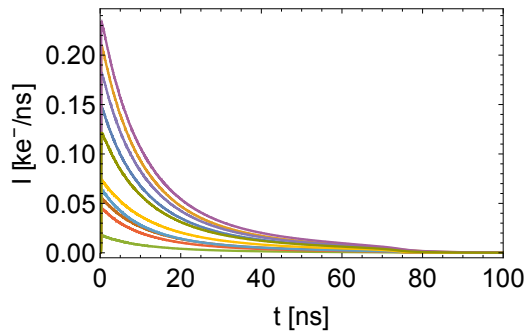
- Model amplifier response and noise (Currently)
- Simulate how bigger pads affect noise
- See what happens when we put a bigger pad above top metal layers

# Time dependent signal

Current induced by electrons



Current induced by ions



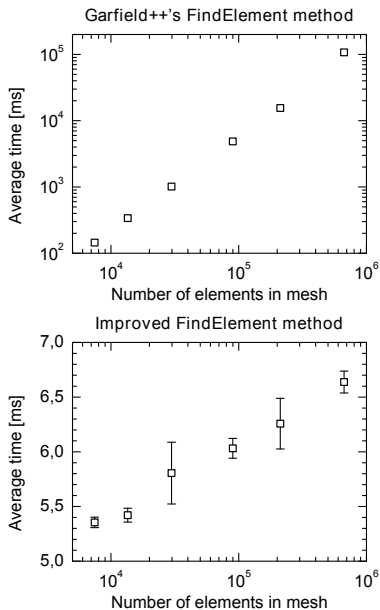
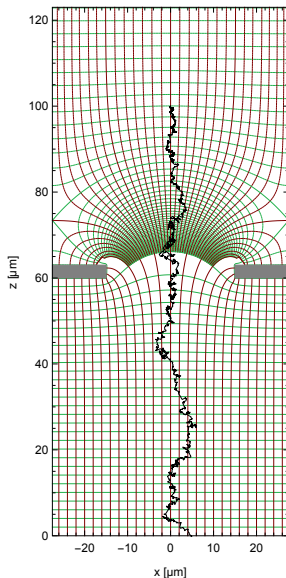
# Speeding up Garfield++

- FindElement function was taking up  $> 90\%$  of computation time
- Measure average time to find elements along an electron track consisting of 7695 points
- Garfield++'s FindElement:  $\mathcal{O}(n)$
- Improved FindElement:  $\mathcal{O}(\log n)$

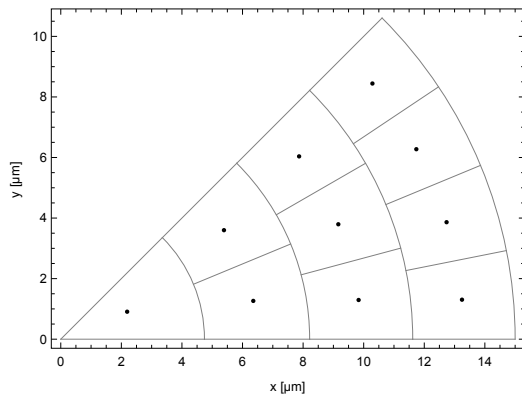
## Speedup for my mesh:

- FindElement:  $\sim 62$  times faster
- Garfield++:  $\sim 25$  times faster

## Benchmarking event



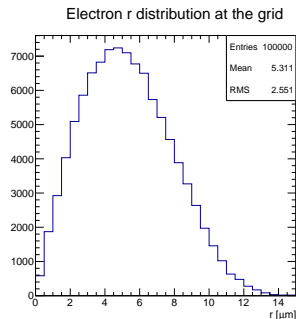
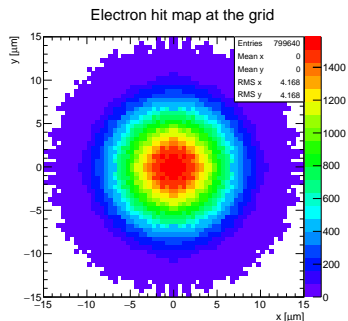
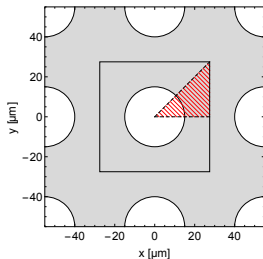
- Separate drift and gain process to decrease computation time
  - 1 Drift electrons to grid plane
  - 2 Partition grid hole into cells of equal area and simulate avalanches for each of them
- Convolve the results





# Drift process

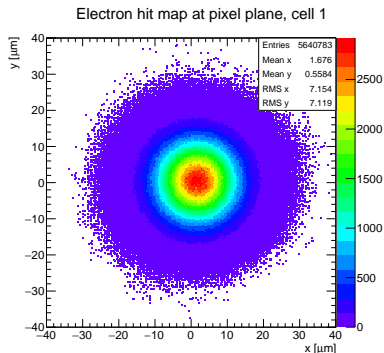
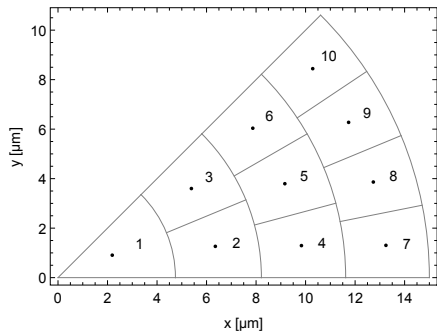
- Generate electrons uniformly in the region  $0 < x < 27.5 \mu\text{m}$ ,  $0 < y < x$ ,  $63 \mu\text{m} < z < 1 \text{ cm}$  and drift them to the grid
- Most electrons arrive at neighbouring pixel cells and are transformed back to the center pixel
- This is equivalent to generating electrons in the region  $-\infty < x < \infty$ ,  $-\infty < y < \infty$ ,  $63 \mu\text{m} < z < 1 \text{ cm}$  and only looking at electrons arriving at a single pixel cell
- 45 out of 100 000 electrons hit the grid



# Gain process

## For each cell:

- Simulate 1000 avalanches at center of cell
- Store a 2D histogram containing electron positions at pixel plane
- Store all gain values
- Note that average pixel plane position  $(\bar{x}, \bar{y})$  depends on cell



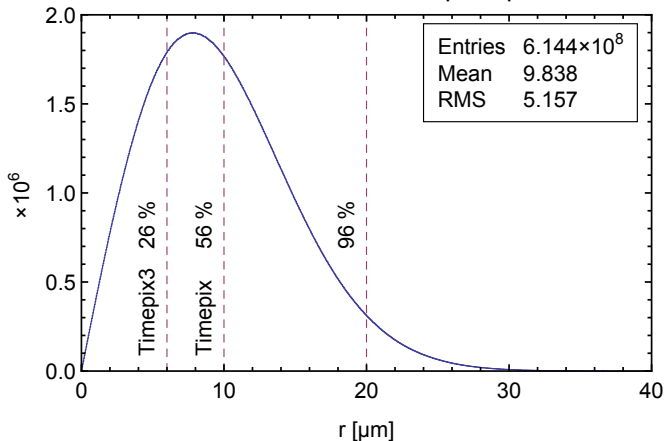
Cell	$\bar{x}$ [ $\mu\text{m}$ ]	$\bar{y}$ [ $\mu\text{m}$ ]
1	1.7	0.6
2	4.7	1.0
3	3.8	2.6
4	7.2	0.9
5	6.7	2.9
6	5.9	4.5
7	10	0.9
8	9.5	2.9
9	9.0	4.8
10	7.8	6.3

# Convolving drift and gain results

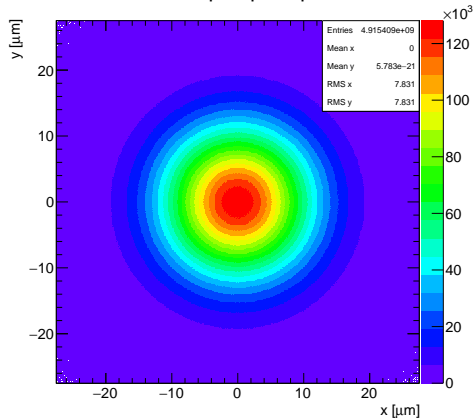
## For each drifted electron:

- Draw random gain  $N$  from corresponding cell
- Draw  $N$   $(\Delta x, \Delta y)$  pairs from cell hit map
- Secondary electrons hit the pixel plane at  $(x + \Delta x, y + \Delta y)$

Electron  $r$  distribution at pixel plane

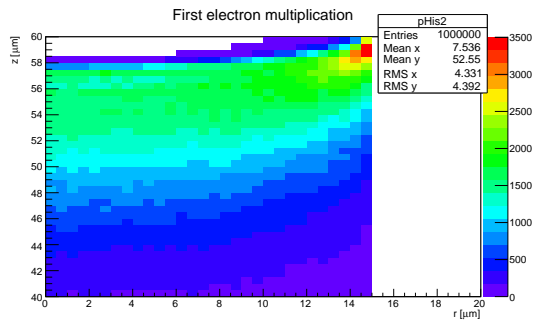
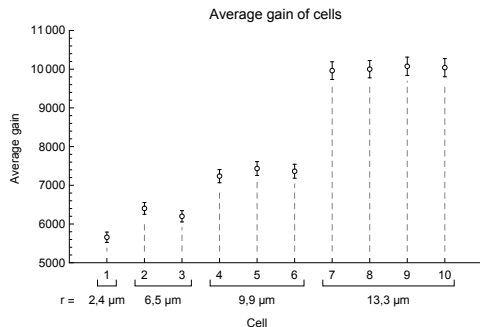


Hit map at pixel plane



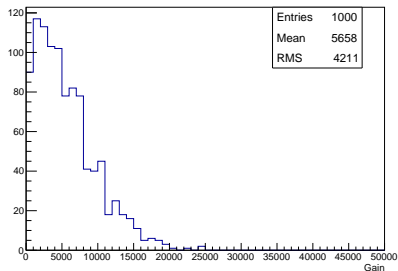
# Gain variation

- Gain depends on where the electron goes through the grid hole
- A factor two difference over the grid hole

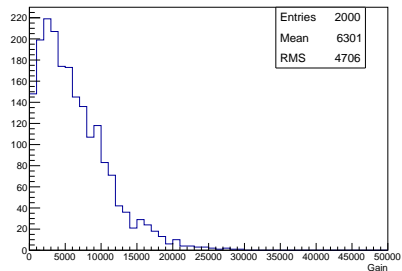


# Gain histograms

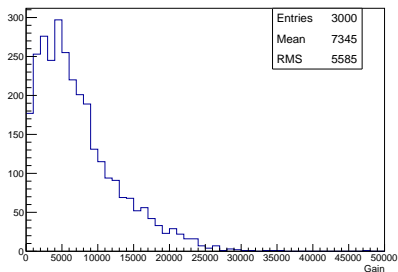
Gain,  $r = 2.4 \mu\text{m}$



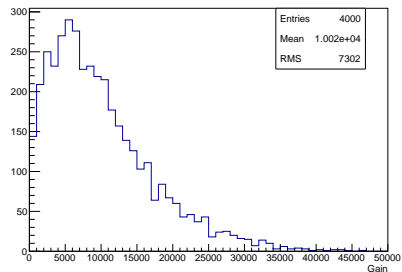
Gain,  $r = 6.5 \mu\text{m}$



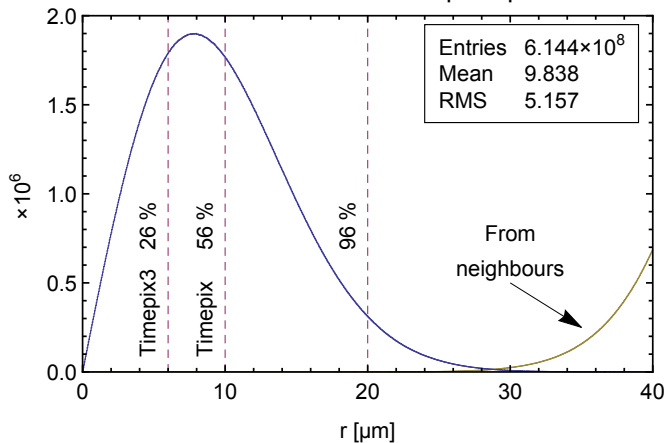
Gain,  $r = 9.9 \mu\text{m}$



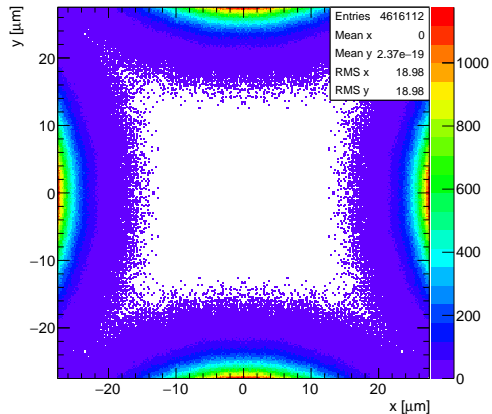
Gain,  $r = 13.3 \mu\text{m}$



## Electron r distribution at pixel plane



## Hit map at pixel plane from neighbouring pixels



# Weighted r distribution

